

Image

2815

AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): Martin E. K rdesch, et al.

Docket No.
90065.001020 (XDEV1100)

Serial No.
09/682,151

Filing Date
July 27, 2001

Examiner
Chris Chu

Group Art Unit
2815

Invention: **CONTACT METHOD FOR THIN SILICON CARBIDE EPITAXIAL LAYER AND SEMICONDUCTOR DEVICES FORMED BY THOSE METHODS**

TO THE COMMISSIONER FOR PATENTS:

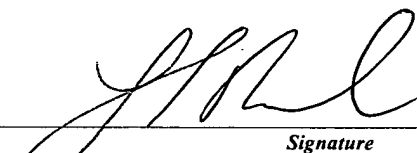
Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	15 -	20 =	0 x	\$18.00	\$0.00
INDEP. CLAIMS	2 -	3 =	0 x	\$86.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

- ☒ No additional fee is required for amendment.
- ☐ Please charge Deposit Account No. _____ in the amount of _____
- ☐ A check in the amount of _____ to cover the filing fee is enclosed.
- ☐ The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No.
- ☐ Any additional filing fees required under 37 C.F.R. 1.16.
- ☐ Any patent application processing fees under 37 CFR 1.17.


Signature

Laurence S. Roach, Esq.
Reg. No. 45,044
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16 E. Main Street, Suite 210
Rochester, New York 14614-1803

Dated: 14-JAN-2004

I certify that this document and fee is being deposited on January 14, 2004 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.


Signature of Person Mailing Correspondence

Penny P. Clements

Typed or Printed Name of Person Mailing Correspondence

CC:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL (37 CFR 1.8)Applicant(s): **Martin E. Kordesch, et al.**

Docket No.

90065.001020/17732.8011.00

Serial No.

09/682,151

Filing Date

July 27, 2001

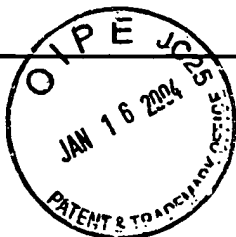
Examiner

Chris C. Chu

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2815

Invention: **CONTACT METHOD FOR THIN SILICON CARBIDE EPITAXIAL LAYER AND SEMICONDUCTOR DEVICES FORMED BY THOSE METHODS**

I hereby certify that this **Amendment (total 13 pages)***(Identify type of correspondence)*

is being deposited with the United States Postal Service as first class mail in an envelope addressed to:

Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

January 14, 2004*(Date)***Penny P. Clements***(Typed or Printed Name of Person Mailing Correspondence)**(Signature of Person Mailing Correspondence)***Note: Each paper must have its own certificate of mailing.**



PATENT
Docket: 90065.001020 (XDEV1100)
Reply to Office Action of 15 Oct. 2003

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

Applicant	:	Martin E. Kordes, et al.)	
Serial No.	:	09/682,151)	Examiner: Chu, Chris
Filed	:	27 July 2001)	Art Unit: 2815
For	:	CONTACT METHOD FOR THIN SILICON CARBIDE EPITAXIAL LAYER AND SEMICONDUCTOR DEVICES FORMED BY THOSE METHODS)	

AMENDMENT

Commissioner for Patents
MS: NON-FEE AMENDMENT
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed 15 October 2003, Applicants hereby submit the following Amendment in compliance with 37 CFR 1.121 as revised in the Final Rule: Changes to Implement Electronic Maintenance of Official Patent Application Records, 68 *Fed. Reg.* 38611 (June 30, 2003).